

# INFLUENCE OF ORGANIC ADDITIVES ON THE ELECTRODEPOSITION OF Cu/Co MULTILAYERS

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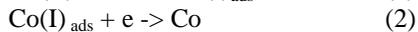
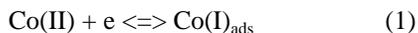
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The electrodeposition of Cu-Co multilayers was investigated in the presence of two additives, sodium dodecyl sulfate (SDS) and saccharin [1, 2]. Cyclic voltametry, steady-state polarization, impedance and potential pulses were carried out, using a quartz crystal microbalance. The magnetoresistance was measured. The experimental conditions have been already described [3].

**Cyclic voltametry** shows that the additives do not markedly affect the discharge of copper, but they have a strong effect on that of cobalt. Saccharin inhibits the deposition whereas SDS has a depolarizing effect.

**Steady-state polarization** - In the presence of saccharin, the polarization curve is shifted towards negative potentials whereas addition of SDS has a slight effect (Fig. 1). Two different slopes are observed depending on the polarization, indicating a two-step discharge of the Co(II) species as for nickel [4].

**Electrochemical impedance** - (Fig. 2). In the basic electrolyte or in the presence of SDS, the double layer capacitance is rather large. In the presence of saccharin, it is markedly decreased, probably as the result of a blocking adsorption of saccharin [5]. The  $R_{t,i}$  product of the charge transfer resistance and the current density, increases with polarization from 45 to 70 mV. The impedance plots exhibit, at low polarization, in addition to the high-frequency capacitive feature, a medium-frequency inductive loop, whose characteristic frequency increases exponentially with polarization. This behavior is quite similar to that observed for the discharge of nickel [4]. As for nickel, this feature is attributed to the two-step discharge of cobalt via an intermediate adion



These reactions are coupled to the hydrogen evolution reaction, written as the global reduction of the protons:



Reaction 1 is considered as a reversible process to account for the increasing  $R_{t,i}$  product with polarization. In the presence of SDS, the kinetics of these reactions are only slightly modified. In the presence of saccharin, a blocking adsorption occurs [5], which inhibits the discharge of cobalt.

**Potential Pulses** - Cu-Co trilayers were prepared at  $E_1 = -0.4\text{V/sce}$  and  $E_2$  at  $-1\text{V/sce}$ , using the EQCM [3]. The frequency shifts were corrected for the mass distribution using the model of Kelly et al [6]. Hydrogen evolution is the main reaction at the beginning of cobalt deposition. This was confirmed by in-situ magnetization measurements [7]. The partial curves for hydrogen evolution are only slightly affected by the additives, whereas the curves for cobalt deposition depend strongly on the presence of the additives (Fig. 3): SDS increases the deposition rate of cobalt whereas saccharin inhibits it.

**Magnetoresistance measurements** were carried out for Cu-Co multilayers deposited on ITO glass ( $t_{\text{Cu}}$ : 4.5nm,  $t_{\text{Co}}$ : 0.8nm). The GMR is  $9 \pm 0.5\%$  in the presence of both

additives, whereas it is 25% for multilayers deposited from the basic electrolyte as shown for other additives [8].

## REFERENCES

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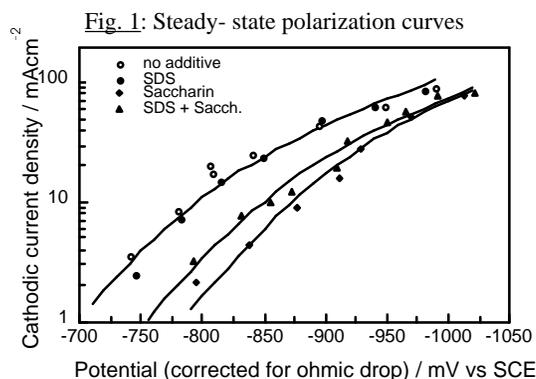


Fig. 1: Steady- state polarization curves

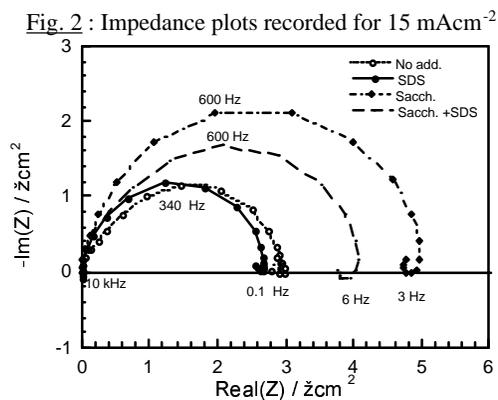


Fig. 2: Impedance plots recorded for 15 mAcm<sup>-2</sup>

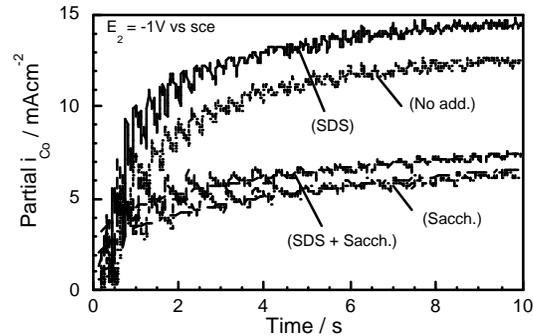


Fig. 3: Transient polarization curves for Co deposition